



EV550717305

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/705,371  
Confirmation No. .... 4350  
Filing Date ..... November 10, 2003  
Inventor..... Brian E. Cron  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 3723  
Examiner ..... A. Ojini  
Attorney's Docket No. .... MI22-2430  
Customer No. .... 021567  
Title: Methods for Conditioning Surfaces of Polishing Pads After Chemical-Mechanical  
Polishing

**PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING**

To: Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-450

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**AMENDMENTS**